

Special Issue

Advances in Additive Manufacturing of 2D/3D Electronic Applications

Message from the Guest Editors

The new form of industrial production is demanding the generation of new, intelligent manufacturing processes which are more customizable, resulting in smaller production batches and more waste. Additive manufacturing (AM) is seen as a powerful enabler for circular economy, which allows materials to be used as long as possible. Thanks to efforts in both the academic and industrial arenas, more and more advanced technologies and applications in AM have been explored. This Special Issue is devoted to electronics applications of AM technologies. Printed electronics and 3D printing are typical AM technologies. In addition, more hybrid technologies have been developed. Thus, authors are welcome to demonstrate the benefit of integrating AM and materials development technologies into other advanced manufacturing approaches. Both in situ and post-processing technologies have been developed to fabricate electronic components, which can be applied into the development of functional devices, such as circuits, sensors, flexible electronics, wearable electronics, etc. Applications can range from the microscale to the macroscale and from research to industry.

Guest Editors

Dr. Qiuquan Guo

Shenzhen Institute for Advanced Study, University of Electronics Science and Technology of China, Shenzhen 518110, China

Dr. Dongxing Zhang

Shenzhen Institute for Advanced Study, University of Electronics Science and Technology of China, Shenzhen 518110, China

Deadline for manuscript submissions

closed (20 December 2021)



Applied Sciences

an Open Access Journal
by MDPI

Impact Factor 2.5
CiteScore 5.5



mdpi.com/si/89372

Applied Sciences
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
appls@mdpi.com

mdpi.com/journal/

[appls](https://appls.mdpi.com)





Applied Sciences

an Open Access Journal
by MDPI

Impact Factor 2.5
CiteScore 5.5



[mdpi.com/journal/
applsci](https://mdpi.com/journal/applsci)



About the Journal

Message from the Editor-in-Chief

As the world of science becomes ever more specialized, researchers may lose themselves in the deep forest of the ever increasing number of subfields being created. This open access journal Applied Sciences has been started to link these subfields, so researchers can cut through the forest and see the surrounding, or quite distant fields and subfields to help develop his/her own research even further with the aid of this multi-dimensional network.

Editor-in-Chief

Prof. Dr. Giulio Nicola Cerullo
Dipartimento di Fisica, Politecnico di Milano, Piazza L. da Vinci 32,
20133 Milano, Italy

Author Benefits

Open Access:

free for readers, with article processing charges (APC) paid by authors or their institutions.

High Visibility:

indexed within Scopus, SCIE (Web of Science), Ei Compendex, Inspec, CAPlus / SciFinder, and other databases.

Journal Rank:

JCR - Q2 (Engineering, Multidisciplinary) / CiteScore - Q1 (General Engineering)